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/ Ruth Montalvo Date: 10/25/04

Docket No.:GK-ZEI-3214/500343.20225

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Customer No. 26418
Applicant: Hans-Juergen Dobschal et al
Serial No.: 10/626,130
Filed: July 24, 2003
For: IMAGING SYSTEM FOR A MICROSCOPE BASED ON
EXTREME ULTRAVIOLET (EUV) RADIATION

AMENDMENT

Commissioner for Patents
P.O Box 1450
Alexandria, VA 22313-1450

Sir:

In response to an Office Action dated July 23, 2004, please amend the above-identified application as follows.